

**S/N 10/681,481**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Paul A. Farrar  
Serial No.: 10/681,481  
Filed: October 8, 2003

Examiner: Joy Watson  
Group Art Unit: 1792  
Docket: 1303.112US1  
Confirmation No.: 7468

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

**PETITION FOR A ONE-MONTH EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with the provision of 37 C.F.R § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Amendment Under 37 C.F.R. § 1.111 mailed February 12, 2008, said period of response being extended from May 12, 2008 to June 12, 2008.

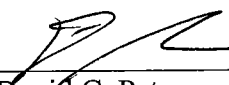
**Please charge Deposit Account No. 19-0743 in the amount of \$120.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully submitted,

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 373-6944

Date 6 - 12 - 2008

By

  
David C. Peterson  
Reg. No. 47,857

**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 12 day of June, 2008.

LeShere Wolfe  
Name

LeShere Wolfe  
Signature